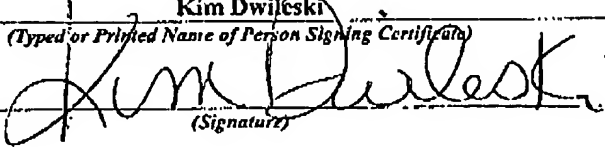


CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No. BUR920030189US1
Applicant(s): Anthony J. Stamper			
Application No. 10/709,722	Filing Date 5/25/2004	Examiner Chu, Chris C.	Group Art Unit 2815
Invention: METHOD OF FORMING A SEMICONDUCTOR DEVICE HAVING AIR GAPS AND THE STRUCTURE SO FORMED			
<div style="text-align: right;">RECEIVED CENTRAL FAX CENTER FEB 02 2006</div> <p>I hereby certify that this <u>Request for Reconsideration (13 pages)</u> <small>(Identify type of correspondence)</small> is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>571-273-8300</u>) on <u>2/2/2006</u> <small>(Date)</small></p> <div style="text-align: center;"><p><u>Kim Dwileski</u> <small>(Typed or Printed Name of Person Signing Certificate)</small></p> <small>(Signature)</small></div> <p style="text-align: center;">Note: Each paper must have its own certificate of mailing.</p>			

DOCKET NO.: BUR920030189US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Anthony K. Stamper

Examiner: Chu, Chris C.

Serial No.: 10/709,722

Art Unit: 2815

Filed: 05/25/2004

Title: **METHOD OF FORMING A SEMICONDUCTOR DEVICE HAVING AIR GAPS
AND THE STRUCTURE SO FORMED**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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REQUEST FOR RECONSIDERATION

Sir:

This Request for Reconsideration is in response to the Final Office Action mailed
December 16, 2005.

10/709,722

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